

Notice of References Cited	Application/Control No. 10/591,505		Applicant(s)/Patent Under Reexamination HIRMER ET AL.	
	Examiner Monique R. Jackson		Art Unit 1787	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,247,799	06-2001	Sakamaki et al.	347/68
*	C	US-2003/0128496	07-2003	Allen et al.	361/306.3
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	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.